

Office of Nonproliferation and Verification Research & Development

# **SNM Movement Detection / Radiation Sensors and Advanced Materials Portfolio Review**

## *RadSensing2011*

# **Electro Optic Detector for Tracking Ionizing Radiation Events**

Lorraine Sadler

**Sandia National Laboratories**

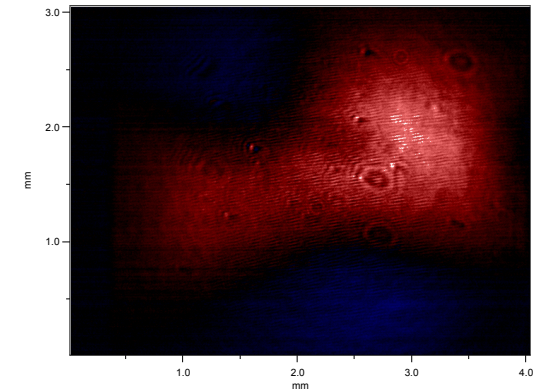
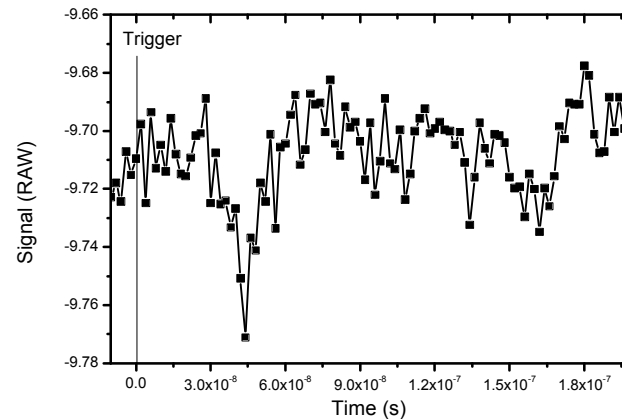
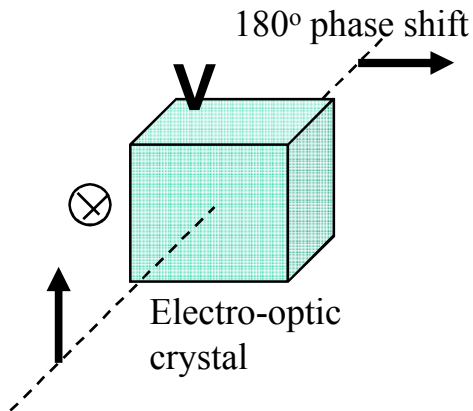
June 8, 2011

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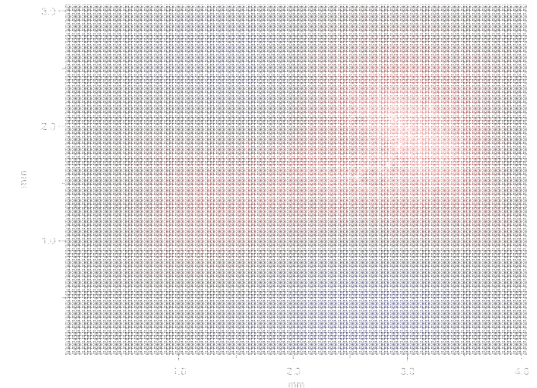
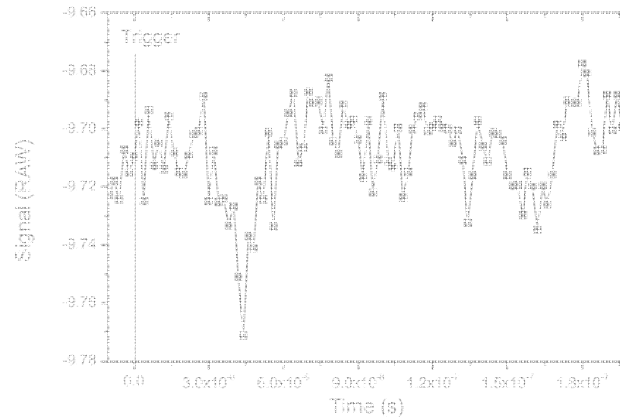
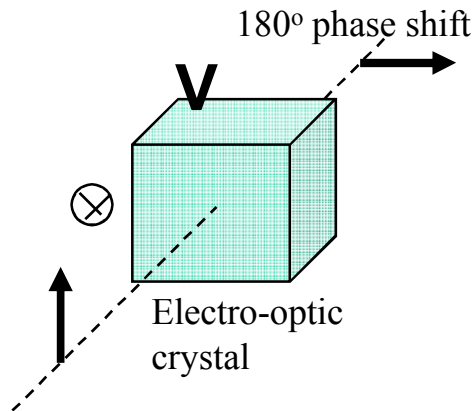
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**Unclassified**

- **Electro-optic detector motivation/background**
- **Timing information for the signal**
- **Imaging of X-rays in an electro-optic crystal**
- **Conclusion**



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# Background: Novel Radiation Detector Need



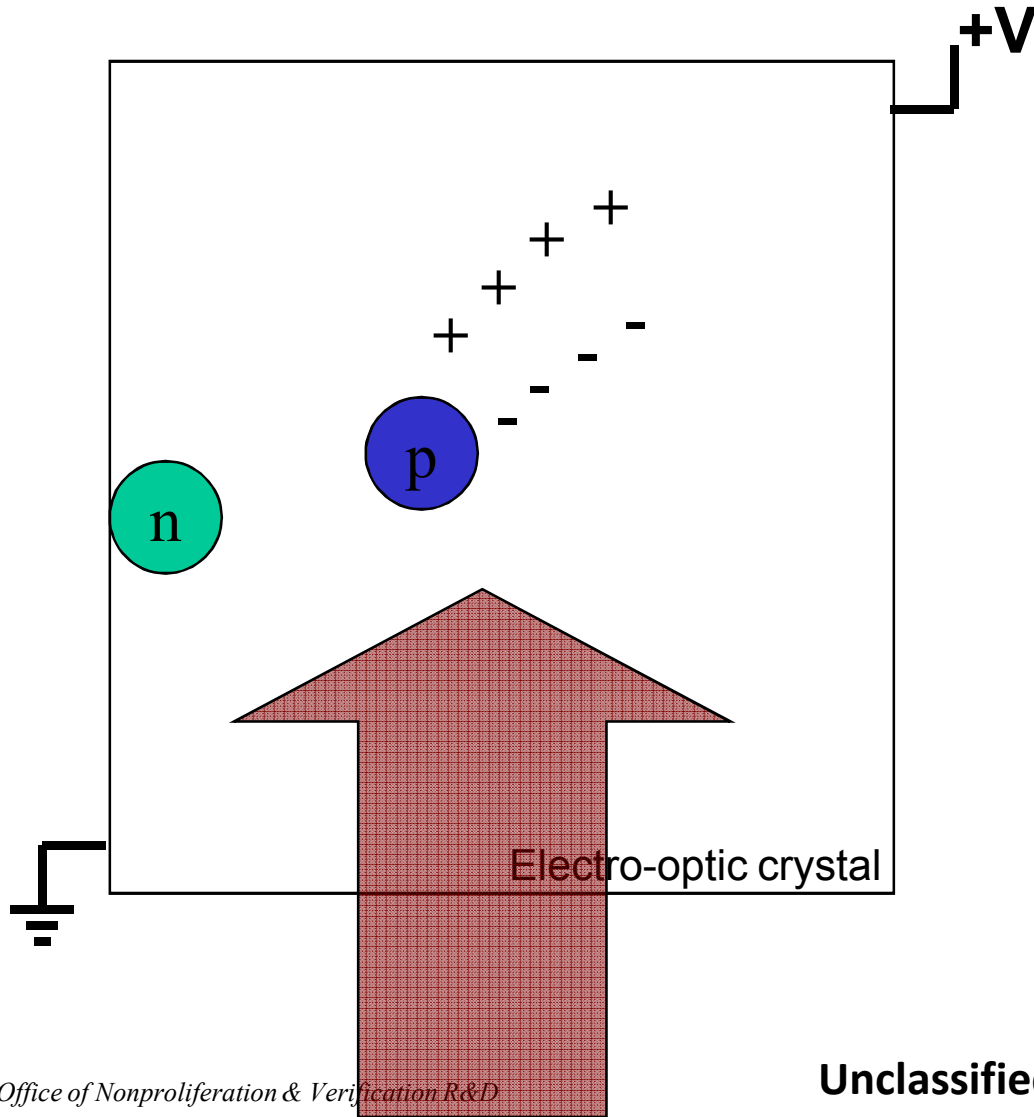
- **Standard radiation detectors have been identified as having shortfalls. Signal size (i.e. number of photons or electrons detected) is directly proportional to the energy and type of the incoming particle**
- **Readout mechanisms have limitations**
  - **Scintillating detectors use photomultiplier tubes (PMT) or photodiodes to detect light.**
    - **Best detection – 100 % detection of scintillation light however detector efficiency and solid angle reduce this signal further**
  - **Semiconductor charge collection -difficult geometries and contacts for charge collection and may require cryogenic temperatures**

Priority	Impact	Topic Area	Investment Option
High	High	Photon detection systems	Alternate radiation detection and readout concepts
			Spectroscopy algorithms for signal-starved spectra
		Neutron detection systems	Large-area, thermal neutron detection systems
			Algorithm development for exploitation of time-correlation observables
			Large-area, fission neutron detection systems
		Photon sources	Next-generation accelerator concepts
			Low-energy, monoenergetic, tunable sources
			Development of compact, mobile photon sources
		Neutron sources	Next-generation ion sources
			Robust, human-portable systems
			Directional beams of high-energy neutrons

Long term investment priorities for the SNM portfolio

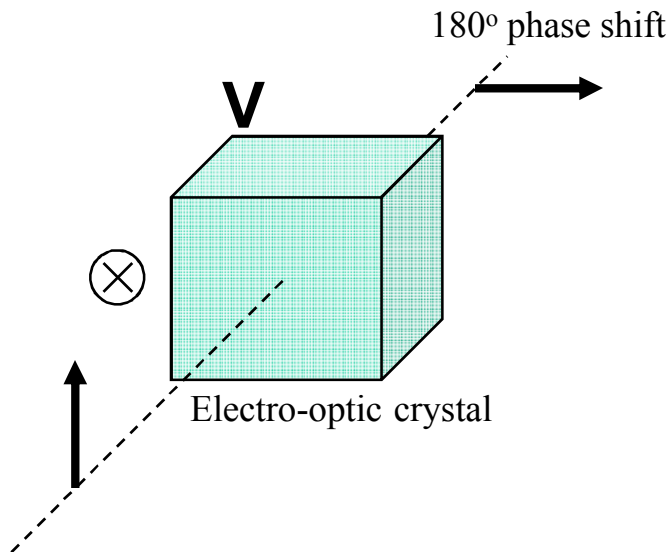
From *Special Nuclear Materials Movement Detection Program Radiation Sensor and Sources Roadmap* NA22-OPD-01-2010

# Electro-optic Detector



- Want to resolve *individual* ionizing radiation events
- Radiation ( $n, \gamma$ ) interacts with the crystal creating electron-hole pairs
- Electrons drift due to an externally applied electric field
- Creates a locally varying electric field inside the crystal
- Due to the radiation interaction a locally varying index of refraction “track” can be probed with laser light
- Light can be analyzed through polarization spectroscopy imaging

# Electro-optic Crystals



- Commercially available crystals include KDP, ADP,  $\text{LiNbO}_3$ ,  $\text{LiTaO}_3$
- Pockels effect- production of birefringence in a noncentrosymmetric crystal that is proportional to the applied electric field
- Applied electric field creates a change in index of refraction  $\Delta n$ .

$$\Delta n = -\frac{n_0^3}{2} r_{63} E_z$$

For KDP

$$n_0 = 1.507$$

$$r_{63} = 11 \times 10^{-12} \text{ m/V}$$

$$E_z = V/d$$



Unclassified

# Electro-optic Detector: New class of Radiation Detectors



- Electro-optic detector is a new class of radiation detectors that does not rely on the collection of scintillation light or charge carriers
- Electro-optic detector relies on the local change in index of refraction of an electro-optic crystal to detect individual radiation particles in real time
- Allows for multiple detection photon interactions with the changed index tracks
- All work is being done at Sandia National Laboratories, Livermore, CA

## Primary Technical Staff:

### – Principle Investigator:

- Lorraine Sadler, *Radiation and Nuclear Detection Systems*

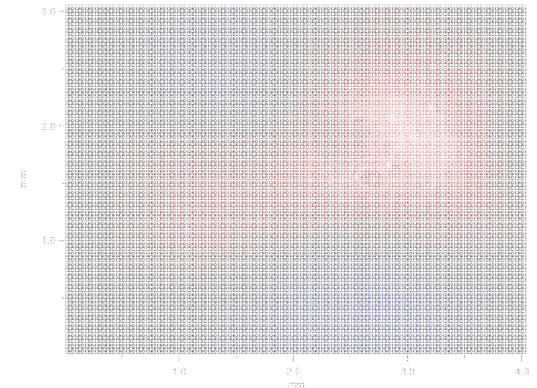
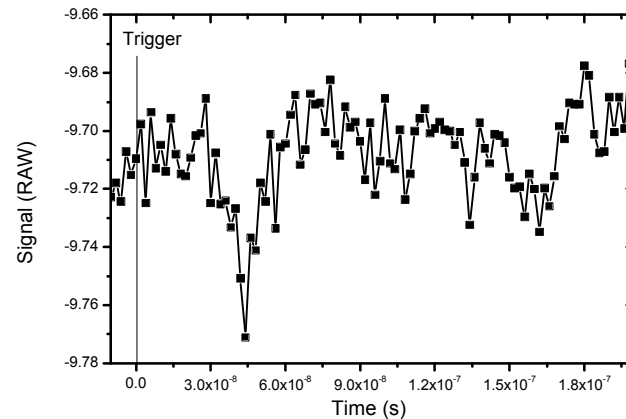
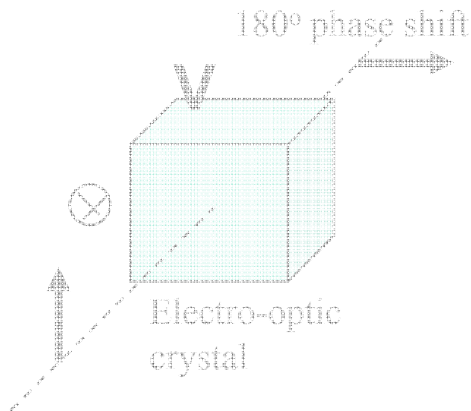
### – Experimental Work

- Scott Bisson and Alex Hoops, *Remote Sensing and Energetic Materials*
- Kevin Strecker, *Combustion Chemistry Department*

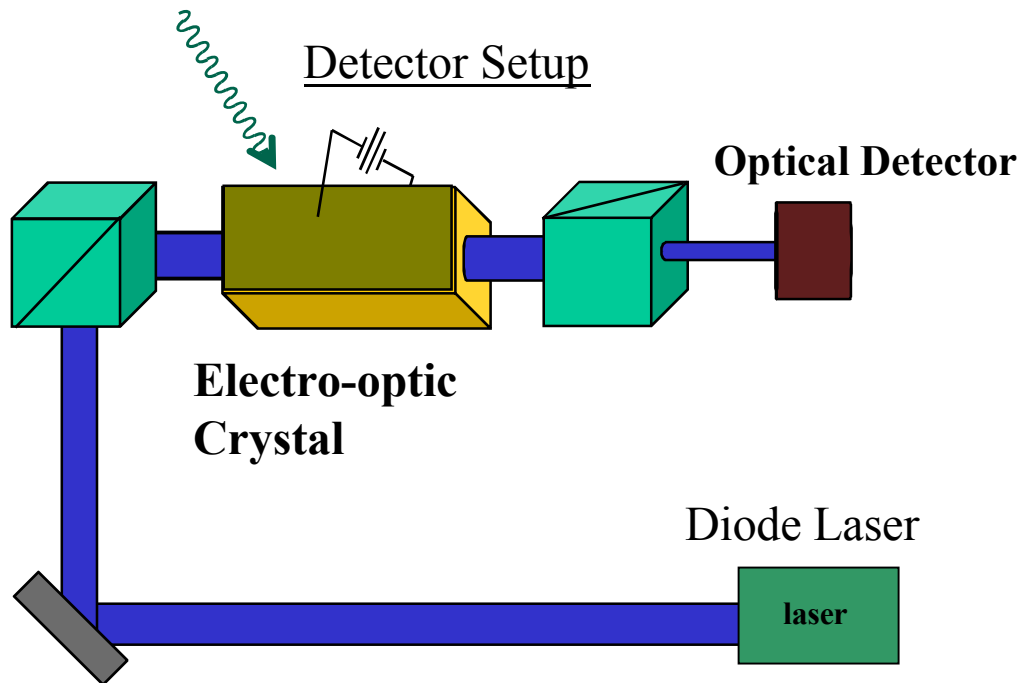
*Budget FY11: \$775 K*



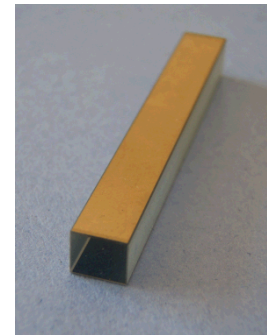
- Electro-optic detector motivation/background
- **Timing information for the signal**
- Imaging of X-rays in an electro-optic crystal
- Conclusion



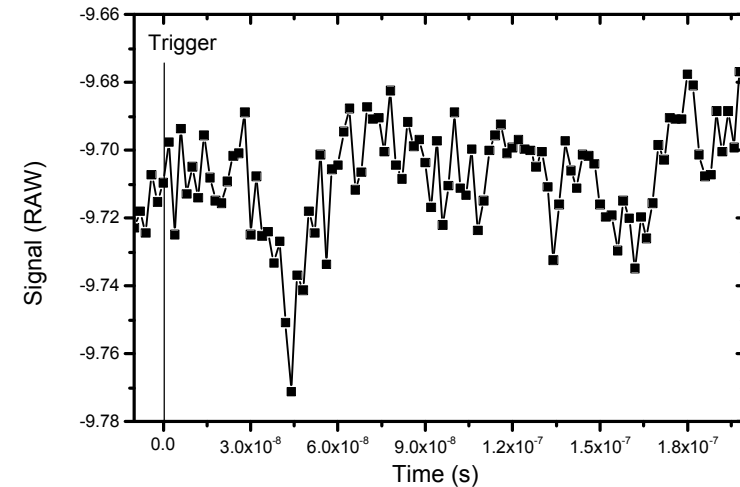
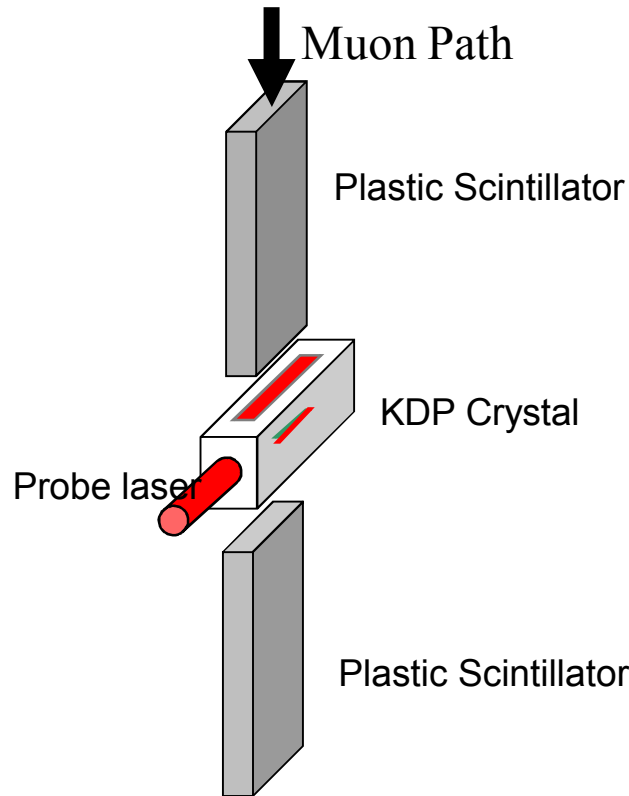
- Uses Polarization Spectroscopy:
  - Crossed polarizers extinguishes the laser beam.
  - Any change in the birefringence of the electro-optical crystal results in more light hitting the detector.



**Typical crystal  
configuration**



# Experimental Parameters

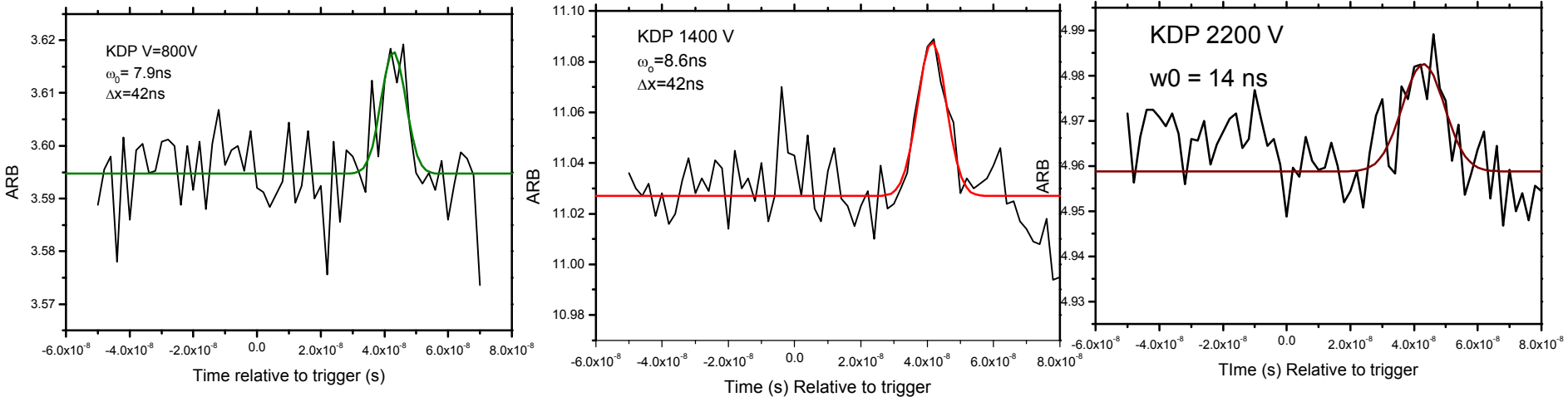


- Requires high light levels on both upper and lower scintillator
- Creates 42 ns delay due to readout
- 0.2 mHz trigger rate

- 4 MeV/cm deposited within the crystal (KDP)
- 50,000 electron-hole pairs
- linear electron-hole pair density of 20 / $\mu\text{m}$ .

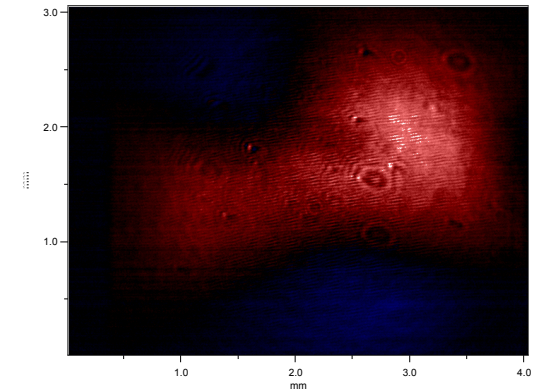
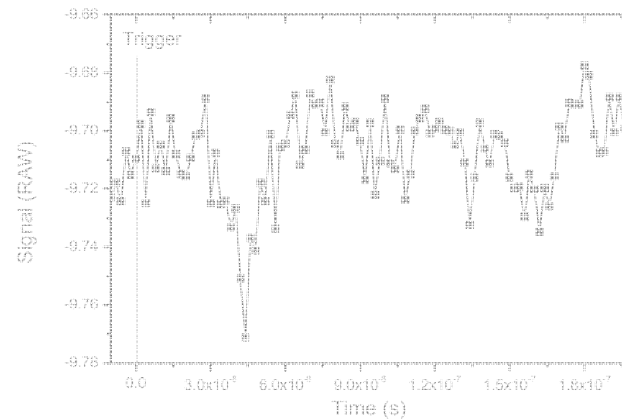
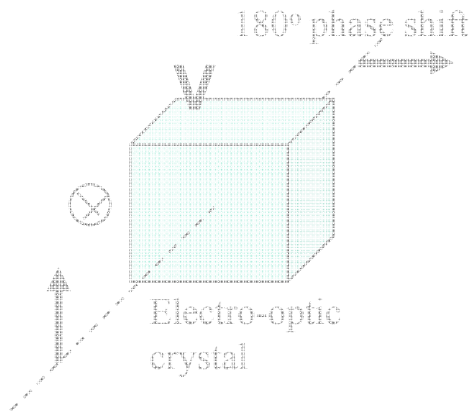
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# KDP: Timing Signals vs. Crystal Voltages

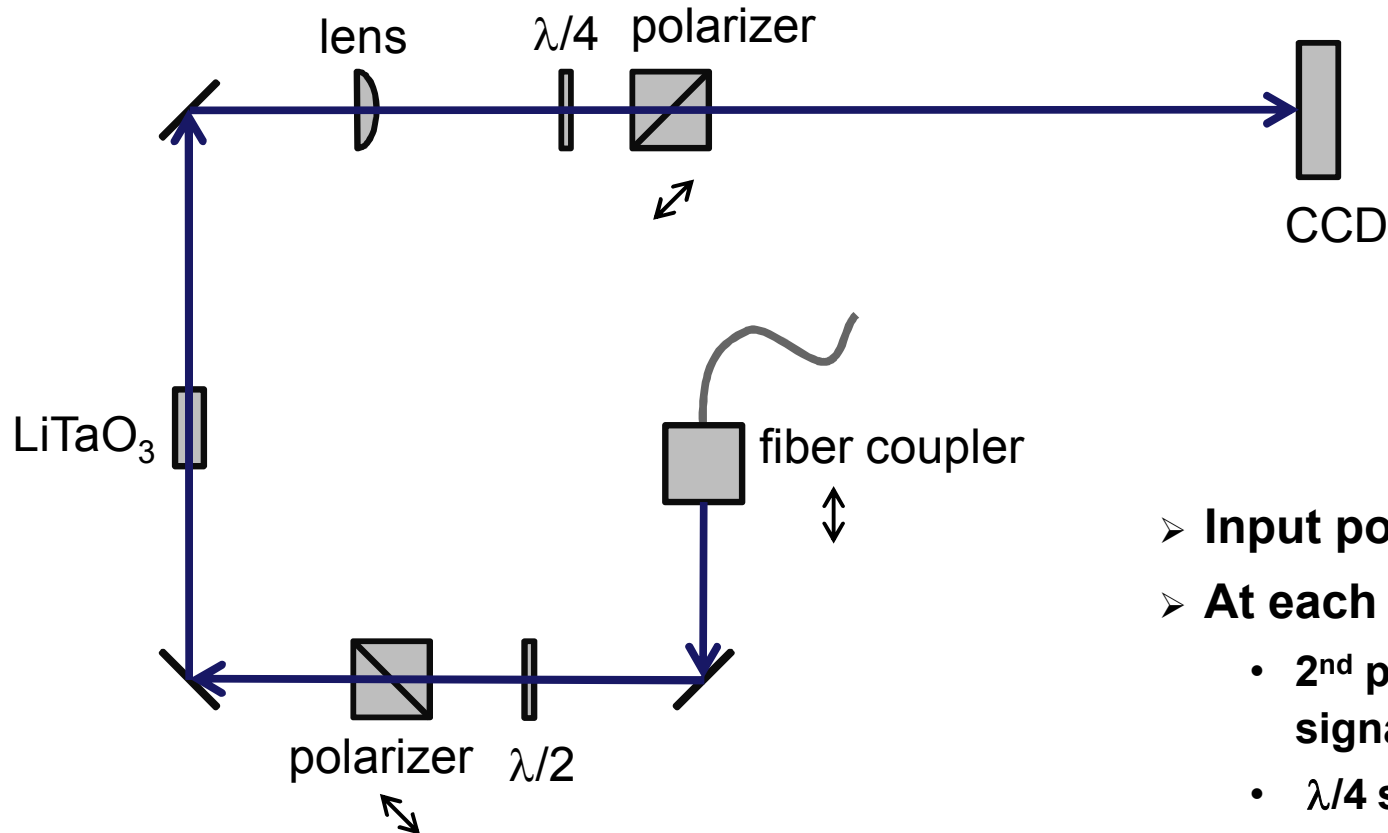


- Average of 130 triggers
- 0.5 % of the light on the tracks is rotated to pass through the cross polarizer
- 0.75 ns / 100 V change in the track duration
- Experimental verification- no signal seen:
  - $V_{\text{crystal}} = 0$
  - Crystal is removed from setup
  - Laser was removed
  - Randomized trigger
- Significant reduction in noise due to polarization impurity
  - Replaced mirrors with metal coatings
  - True 45° light reflections
- Limited by electronic noise

- Electro-optic detector motivation/background
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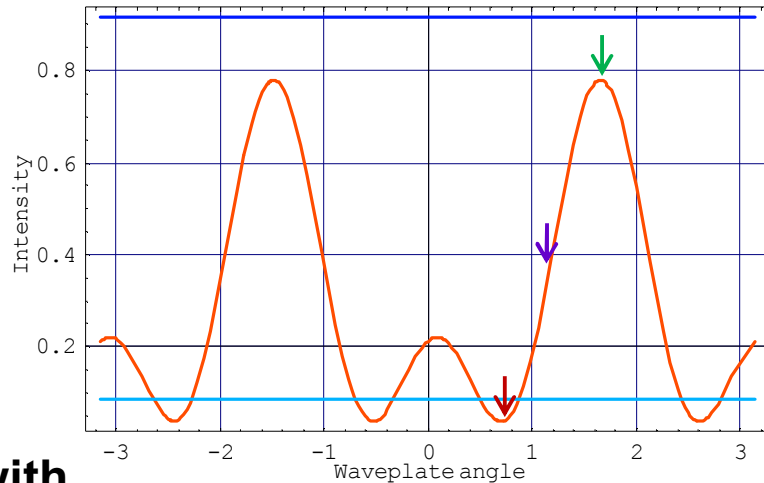
# LiTaO<sub>3</sub> Imaging Experiment



- Input polarization set to 45°
- At each crystal voltage:
  - 2<sup>nd</sup> polarizer set to null signal
  - $\lambda/4$  set to give greatest intensity change with voltage

# Expected Intensity Response

## Intensity response with $\lambda/4$ rotation

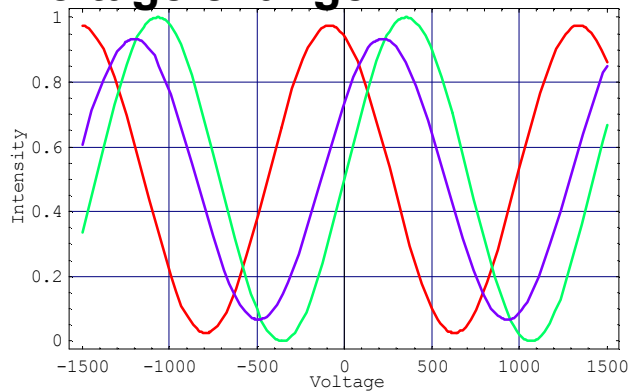


← Max intensity w/o  $\lambda/4$

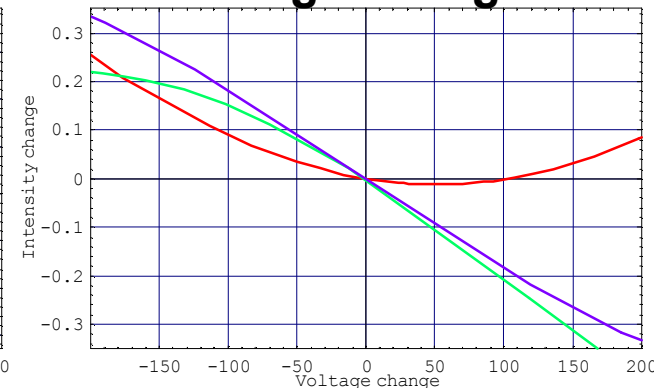
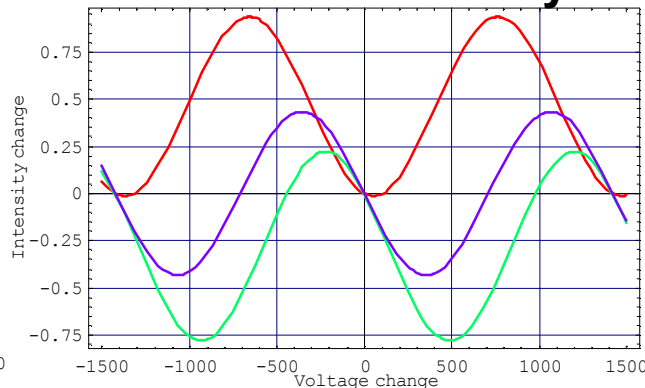
← Intensity w/ $\lambda/4$

← Min intensity w/o  $\lambda/4$

## Intensity response with voltage change



## Intensity delta with voltage change



— Min intensity  $\lambda/4$

— Max intensity  $\lambda/4$

— Max slope  $\lambda/4$

# Exposure of LiTaO<sub>3</sub> to X-rays

- X-ray source: 400 kV / 2 mA / 1 minute
- Applied E-field to crystal:  $+4.0 \times 10^5$  V/m
- CCD camera:
  - **Exposure: 0.426 ms**
  - **Time between images: 6 seconds**
- [X-rays on image 8, off after image 17](#)

Voltage Offset:

-150 V

-100 V

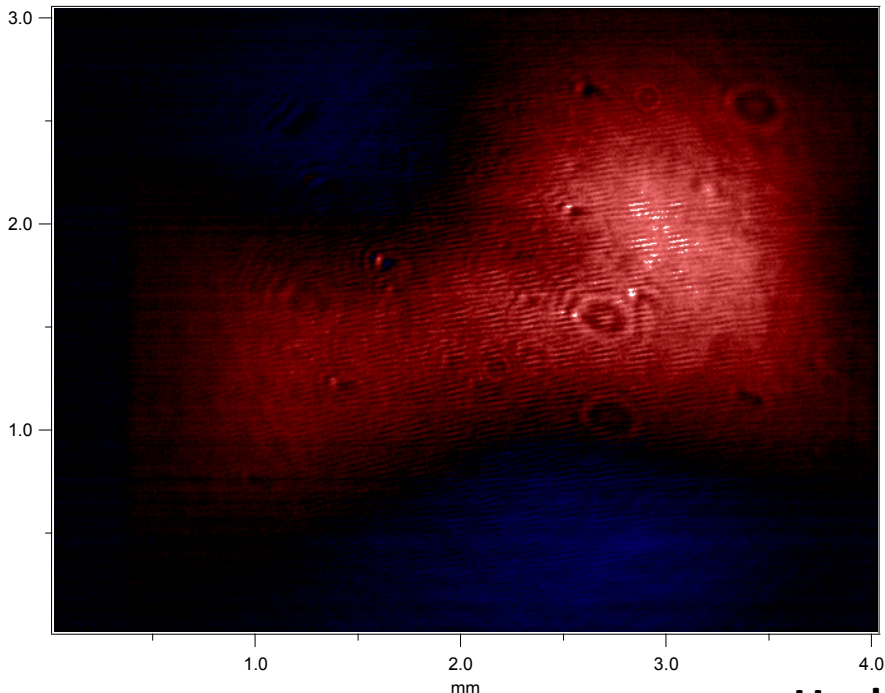
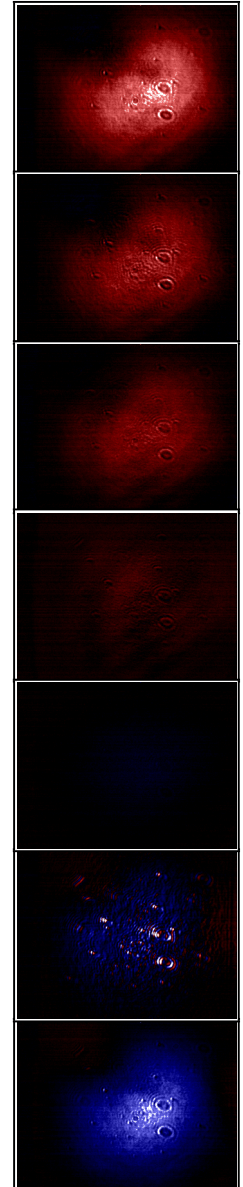
-50 V

0 V

+50 V

+100 V

+150 V

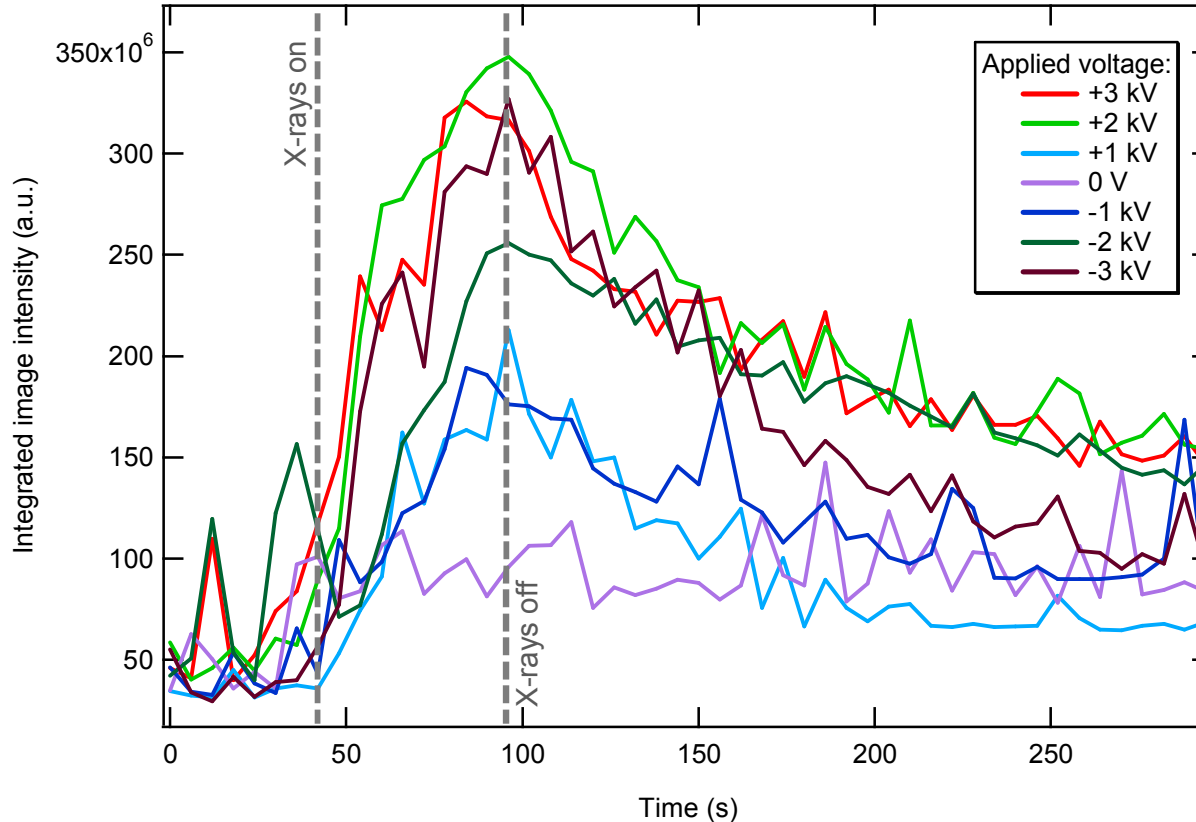


Applied voltage (V)	Max voltage-equivalent change (V)
+3000	-130
+2000	-110
+1000	-110
0	+20
-1000	-60
-3000	+70

Unclassified

# LiTaO<sub>3</sub> Response at Varying Crystal Voltages

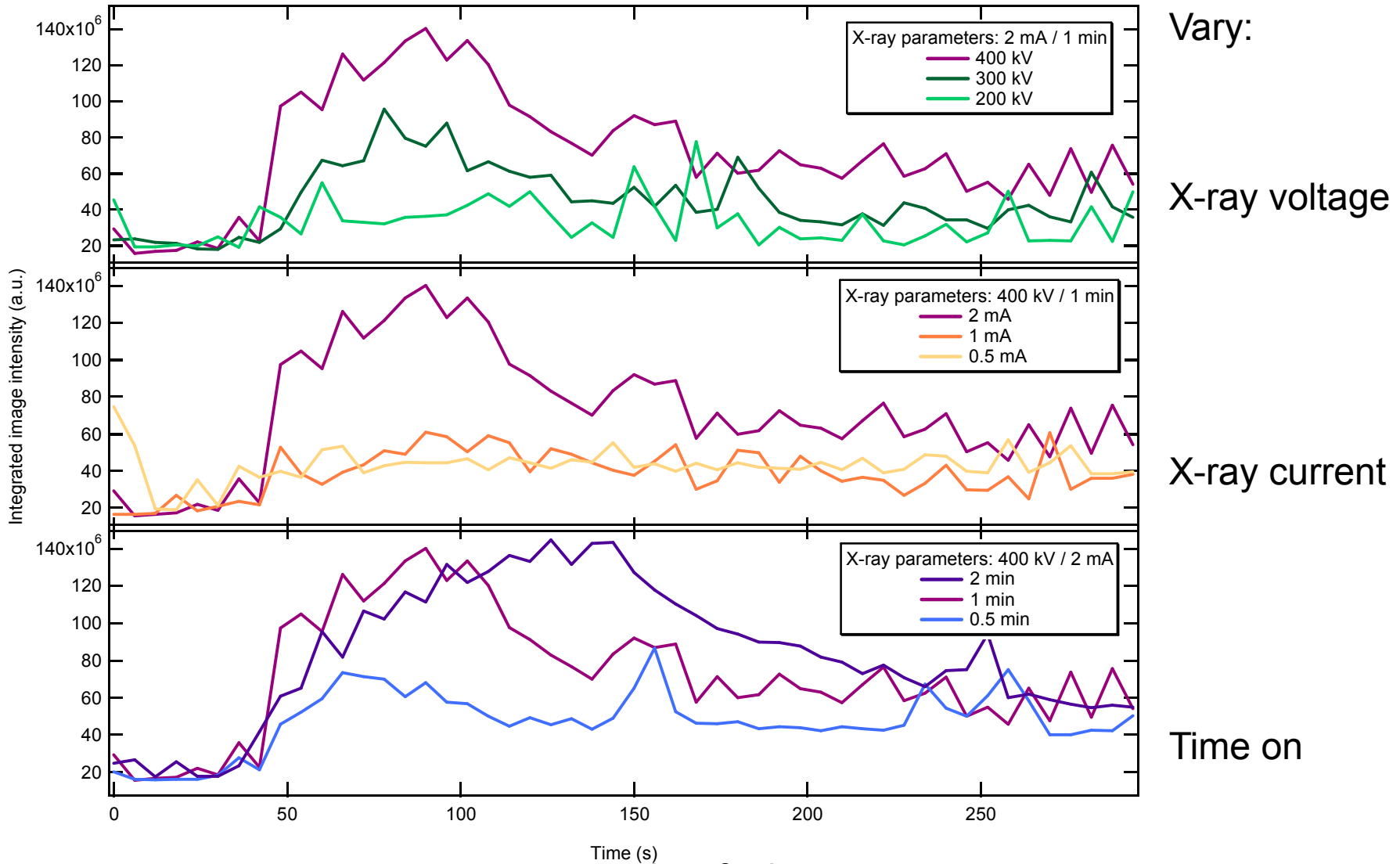
- X-ray source: 400 kV / 2 mA / 1 minute
- X-rays on at image 8, off after image 17



Unclassified

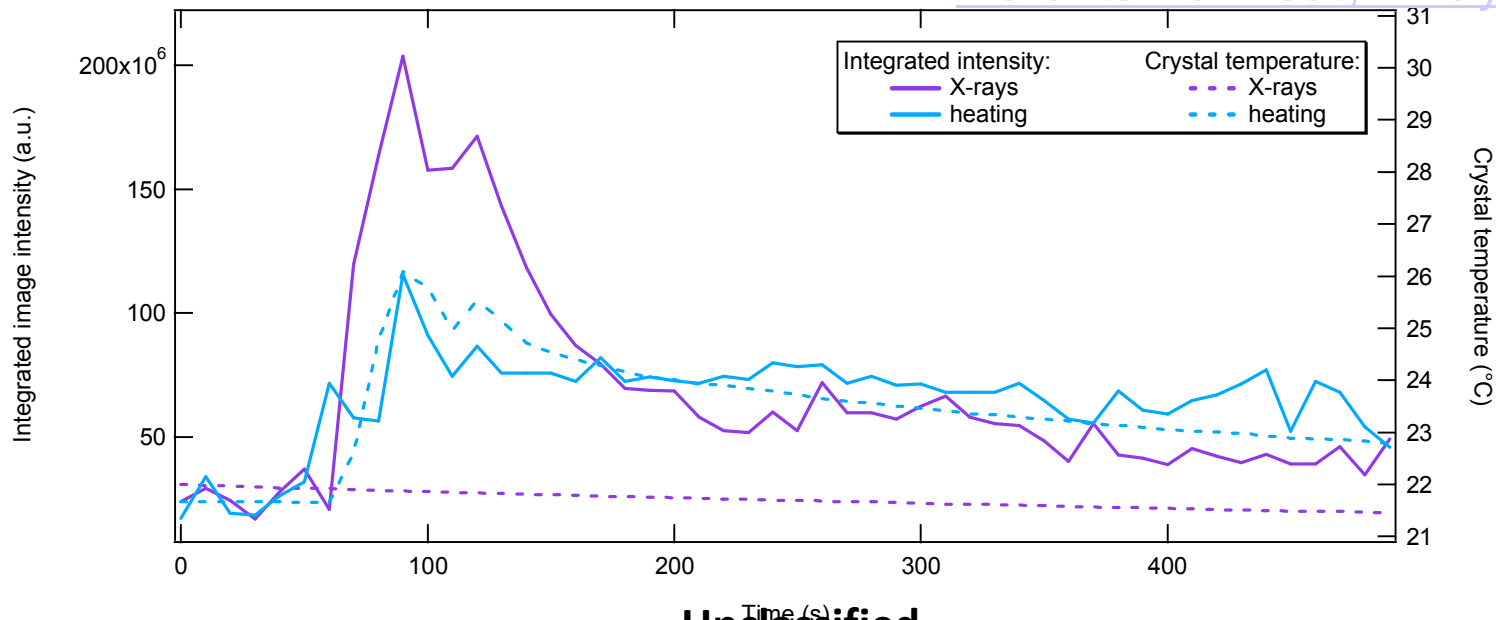
Unclassified  
**LiTaO<sub>3</sub> Response with  
Varying X-ray Parameters**

- Applied E-field to crystal:  $+4.0 \times 10^5$  V/m

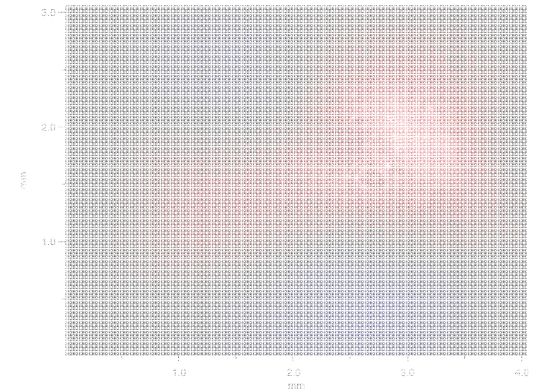
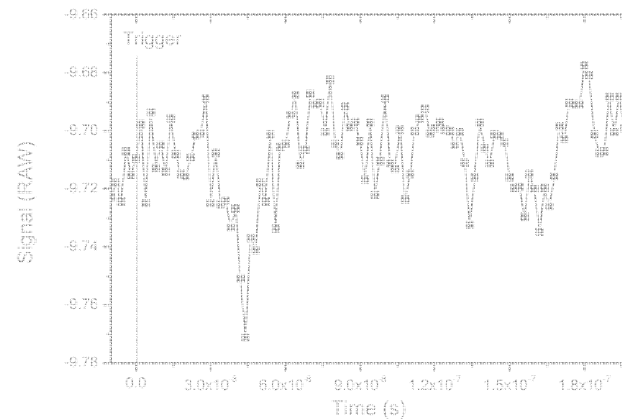
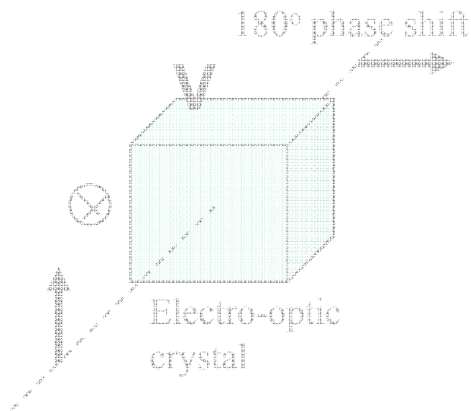


Unclassified  
**Temperature Response of  
LiTaO<sub>3</sub>**

- Applied E-field to crystal:  $-4.0 \times 10^5$  V/m
- X-ray source: 400 kV / 2 mA / 1 minute
- CCD camera:
  - Exposure: 0.682 ms
  - Time between images: 10 seconds
- X-rays on at image 8, off after image 13
- Background-subtracted images:
  - [Heating crystal, no X-rays](#)
  - [No external heat, X-ray exposure](#)



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# Technical Challenges

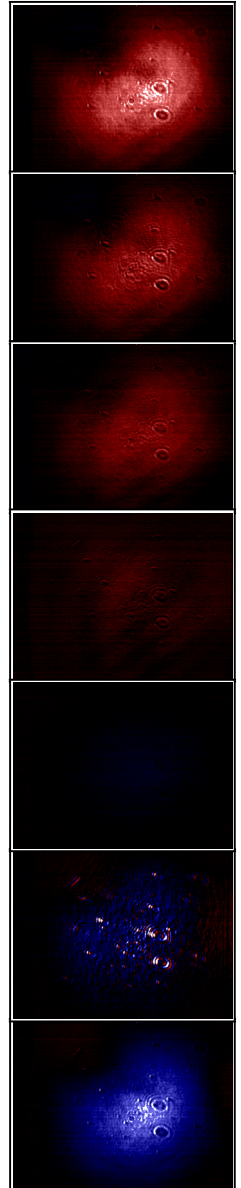
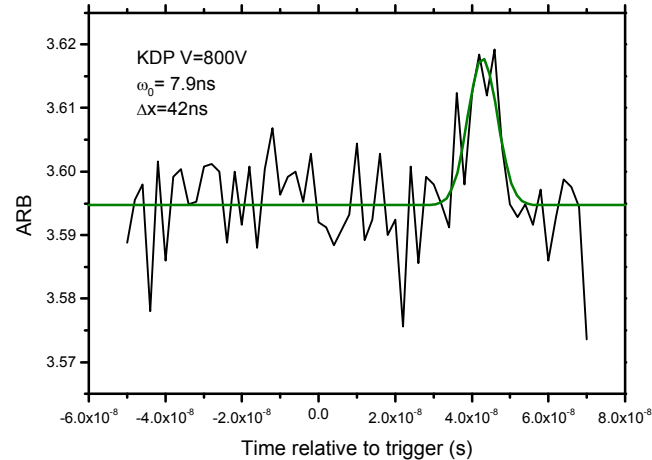


- Determining the physical size of the track in the crystal
- Understanding the response time in  $\text{LiTaO}_3$  crystal
- Increasing the interaction rate of particles in the imaging region
- Distinguishing charged particle interactions within the crystal from background interactions in the CCD camera
- Increasing the interaction region that can be imaged at the appropriate resolution

# Unclassified Summary



- Electro-optic detector is a new class of radiation detector that does not rely on the collection of scintillation light or charge carriers
- Electro-optic detector relies on the local change in index of refraction of an electro-optic crystal to detect individual radiation particles in real time
- Accomplishments
  - Experimentally measured a **7.9 ns lifetime of a change in refractive index due to an cosmic ray (muon) in KDP.**
  - Imaged the internal fields in a **LiTaO<sub>3</sub> crystal**
  - Imaged the change in the index of refraction (bulk effect) in **LiTaO<sub>3</sub> due to 450 keV X-ray source**
- Further Work
  - Understand the parameters of the radiation induced tracks



Unclassified